

Status on R&D of FoCal Pixel Layers

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- Introduction to FoCal
- R&D of FoCal Pixel layers

Summary

Introduction to FoCal





Structure of ALICE detector

- > FoCal is a forward calorimeter as an upgrade to ALICE detector, exploring the small-x parton structure
- FoCal has two components: electromagnetic calorimeter (FoCal-E), hadronic calorimeter (FoCal-H)
- FoCal is located in front of the compensator magnet and outside the magnet doors, opposite the muon arm, about 7 meter to the Interaction Point (IP)
- FoCal installation is foreseen during LS3, to be take data during LHC Run 4 that is currently scheduled during 2030-2033

Sketch of FoCal-E





- FoCal-E includes 20 layers of absorber W (each 3.5mm thick) and Si sensors
- FoCal-E has a hybrid design using two different Si readout technologies
 Si-PAD, low granularity, cell size is 1cm x 1cm, readout by HGCROC chip
 Si-Pixel, high granularity, pixel size is 30µm x 30µm, equipped with ALPIDE chip
- Focal-E includes 18 layers of Si-PAD (measure shower energy and shape) and 2 layers of Si-Pixel (decay proton identification)

Assembly steps for Focal-E detector





- Focal-E Module consists of 5 segments and has 20 module-layers in total
- The first 2 segments have 4 Si-PAD module-layers and 1 Si-Pixel module-layer, and the last 3 segments only have Si-PAD module-layers (4+4+2)
- Focal-E has a total of 22 modules, 11 on each side of the beam pipe

Focal-E pixel layer cross section





- Total thickness: 3.5(absorber)+1.5(spacer)+1(carrier)+1(carrier)+1.5(spacer)=8.5mm
- Pixel layer assembly at CCNU, module assembly at CERN

Focal-E Pixel Layer assembly







Pixel layer assembly jig

Half Layer module

Single ALPIDE Assembly - SpTAB bonding





F&K Delvotec G5 64000

Wire bonding



SpTAB bonding



Chip-to-flex



Flex-to-flex

Single ALPIDE Assembly - SpTAB bonding



SPT company 7000/7100 tool style

STANDARD DIMENSIONS					
7000, 7045 Tool Style			7100, 7145 Tool Style		
W/FL	Foot Wifth W in / μm ±.0002/5	Foot Length FL in / μm ±.0002/5	т	Tip Diameter Τ in / μ <i>m</i> ±.0002/5	
4025 4030 4035 4040 5030 5035 5040 5045	.0040 / 102 .0040 / 102 .0040 / 102 .0040/ 102 .0050 / 125 .0050 / 125 .0050 / 125 .0050 / 125	.0025 / 64 .0030 / 76 .0035 / 89 .0040/ 102 .0030 / 76 .0035 / 89 .0040 / 102 .0045 / 114	0030 0035 0040 0045 0050 0055 0060 0070	.0030 / 76 .0035 / 89 .0040 / 102 .0045 / 114 .0050 / 125 .0055 / 140 .0060 / 152 .0070 / 178	Chipcable- to-chip (trace width 70um) Chipcable- to-flex (trace width 100um)
5050 5055 6045 6050	.0050 / 125 .0050 / 125 .0060 / 152 .0060 / 152	.0050 / 125 .0055 / 140 .0045 / 114 .0050 / 125			



SpTAB bonding with gold plate



Bonding result in microscope

Pull test with DAGE4000

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7000 STYLE

7100 STYLE

Single ALPIDE Assembly





- The Single ALPIDE Bond Tool is fixed on the bonding table and ALPIDE is placed at the center of the Tool by vacuum
- A frame with Chip cable is placed on the Tool through positioning pins to preliminarily align ALPIDE with Chip cable
- Use micro-meter head for high precision alignment of ALPIDE with Chip cable during SpTAB bonding 10

Single ALPIDE Assembly

Cut off the part for assembly

The parts for assembly

- Cut off the parts after bonding (cutting is carried out along the cutting line by hand at present, and a jig will be used during production)
- A Production Test Box has been developed for functional tests before cutting, only the chip pass the tests can be used in pixel layer production
- China Institute of Atomic Energy participates in the development of firmware

Production Test Box

Pixel Layer Assembly

Carrier

FoCal 15 chip jig

Pixel Layer Assembly

2 chip jig

15 chip jig

- Replace bonding needle and do the SpTAB bonding test
- Produce Single ALPIDE Bond Tool and finish single chip module assembly
- Produce Multi Chip assembly jig and do some preliminary tests
- Cutting and bending tools are under development
- CCNU lab is ready for pixel layer module assembly

Thank You !